



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Ju-Cheol SHIN, et al.

Art Unit: 2823

Serial No. 10/678,184

Examiner: Fernando L. Toledo

Filed: October 6, 2003

Confirmation No. 2334

For: METAL INTERCONNECTION WITH LOW
RESISTANCE IN A SEMICONDUCTOR DEVICE (AS
AMENDED)

Attorney Docket No. 262/016 DIV

*Entered
w/ RCE
7/18/05*

**AMENDMENT UNDER 37 C.F.R. § 1.114 and
APPLICANT-INITIATED INTERVIEW SUMMARY**

Commissioner for Patents
United States Patent and Trademark Office
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

INTRODUCTORY COMMENTS

In connection with the Request for Continued Examination filed concurrently herewith, the following amendments and remarks are respectfully submitted in connection with the above-identified application:

Amendments to the Claims are reflected in a listing of the claims, which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.